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Patent Reference: P-0342.010-US

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: **JAN EVERT VAN DER WERF et al.**

Application No.: 10/618,264  
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Confirmation No.: 3943  
Group No.: 2878  
Examiner:

For: **LITHOGRAPHIC APPARATUS AND DEVICE MANUFACTURING METHOD**

**Commissioner for Patents**  
**P.O. Box 1450**  
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**SUPPLEMENTAL APPLICATION DATA SHEET**  
**37 C.F.R. § 1.76(c)**

The following information on the Application Data Sheet is changed as indicated:

**BIBLIOGRAPHIC DATA**

**1. Assignee information is being modified.**


The assignee(s) of this application is/are:

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**Extent of interest of assignee in application: ENTIRE RIGHT, TITLE AND INTEREST**

Date: June 3, 2004

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